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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a 371 of PCT/JP04/11101 07/28/2004 [-GDB]

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2003-289442 08/07/2003 [-GDB]  
 JAPAN 2003-289443 08/07/2003 [-GDB]  
 JAPAN 2003-317395 09/09/2003 [-GDB]  
 JAPAN 2004-003654 01/09/2004 [-GDB]  
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## \*\* IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\*

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| Foreign Priority claimed       | <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No | <input type="checkbox"/> Met after Allowance<br>GDB<br>Initials | STATE OR COUNTRY<br>JAPAN | SHEETS DRAWINGS<br>35 | TOTAL CLAIMS<br>61 | INDEPENDENT CLAIMS<br>8 |
|--------------------------------|---|---|---------------------------|-----------------------|--------------------|-------------------------|
| 35 USC 119(a-d) conditions met | <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No |   |                           |                       |                    |                         |

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## TITLE

Substrate processing apparatus, substrate processing method, and substrate holding apparatus

|                             |   |  |
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